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U.S. PATENT DOCUMENTS

Examiner Initials	Document Number (Number-Kind Code)	Publication Date (MM-DD-YYYY)	Name of Patentee or Applicant	Class	Sub-class
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	JP 2002-216570	02/08/2002	Semiconductor Energy Lab Co. Ltd	Translation /Abstract

OTHER DOCUMENTS (Author (Capitalize), Title, Date, Pages, Etc., if known)

Examiner's Signature: /Robert Rainey/

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